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Micromegas Particle Detector

Nuclear Physics SBIR/STTR Exchange Meeting

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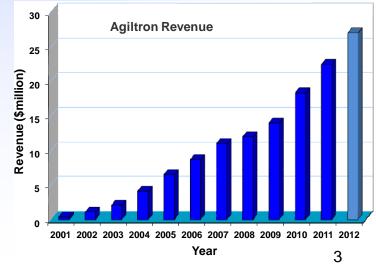
- Company Background
- The Need
- Agiltron Approach
- Experimental Results

Agiltron At A Glance



- Established 2001
- Over 100 employees
- \$27 million projected 2012 revenue
- 60,000 sq. ft. R&D, manufacturing, and administrative facilities
- ISO 9001 certified optical systems manufacturer
- Inc 500, Deloitte Fast 50 & 500, SBANE Innovation Awards

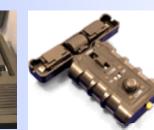




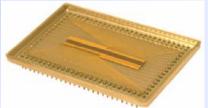
Agiltron's Business Model

- Optical component and systems developer and manufacturer
- Revenue streams
 - Product sales
 - Funded R&D
- Product divisions
 - Fiberoptic Components
 - Infrared Detectors
 - IR and Thermal Imaging
 - Raman Spectroscopy
 - Functional NanoMaterials
- Vertically integrated
- Infrastructure investment
 - People / Equipment / Facilities
- Product differentiation by advanced development





Fiberoptic Repair Kit PEO(T) / PMA 260 / PMA 265



PbS / PbSe IR Detectors



Non-Mechanical Switch F-35 JSF



Raman Spectrometers

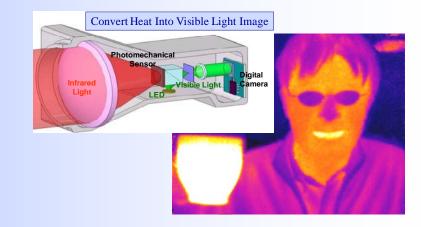


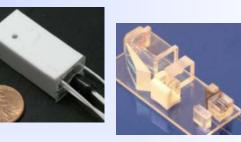
Microfabrication Equipment Stille 4

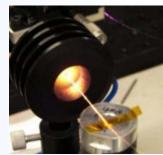
Key Development Areas

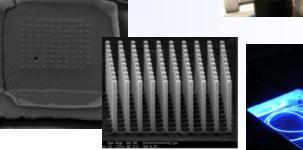
- Chem/Bio/Radiation
 Detectors
- IR Detectors and Optics
- HFI Sensors
- Photomechanical Imaging
- Microwave Photonics
- Nanomaterials and Devices







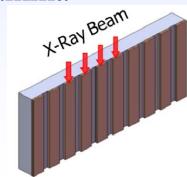


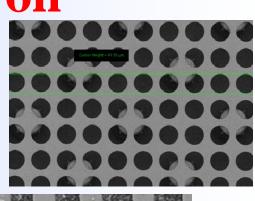


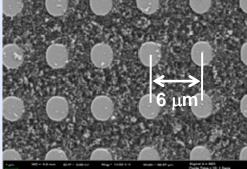
High Energy Particle Detection AGILTRON Programs in Agiltron

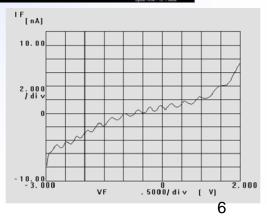
Micromegas

- DOE SBIR Phase II
- Silicon Microfabricated Neutron Detectors
- Nano-Particle Loaded Polymer X-Ray Detector
- Low Cost Microfabricated Gamma Detectors







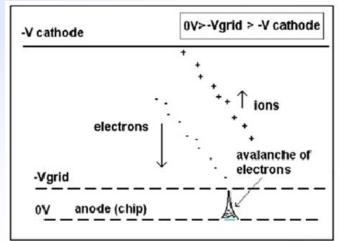


The Need



Nuclear physics research need position sensitive charge particle and gamma ray tracking devices

- Micromegas exhibits excellent stability, fast response, excellent spatial uniformity and energy resolution, and exceptionally high positive ion collection efficiency.
- But needs further improvements in performance and reproducibility which can be achieved by microfabrication.



Agiltron's Approach



- Design and fabricate mesh with necessary structural integrity, flatness, parallelism and spark-resistance.
- Develop and fully optimize micromegas device structures, and micro-fabrication and assembly procedures for low cost manufacturing in large areas.

Agiltron's goal is to significantly improve the high energy particle detector performance, and become a leading commercial supplier of instrument-grade radiation detectors; and compact/low cost/high volume radiation detectors

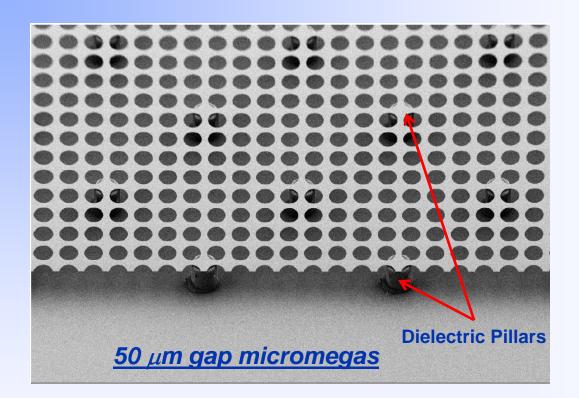


Features & Benefits

Features	Benefits
Specially Designed Mesh Electrode	 Spark-resistance and long life Durable performance High gain Tunable performances
Micro-Fab Process	 Accurate dimensional control Uniform performance in large areas Design flexibility Scalable Low manufacturing cost



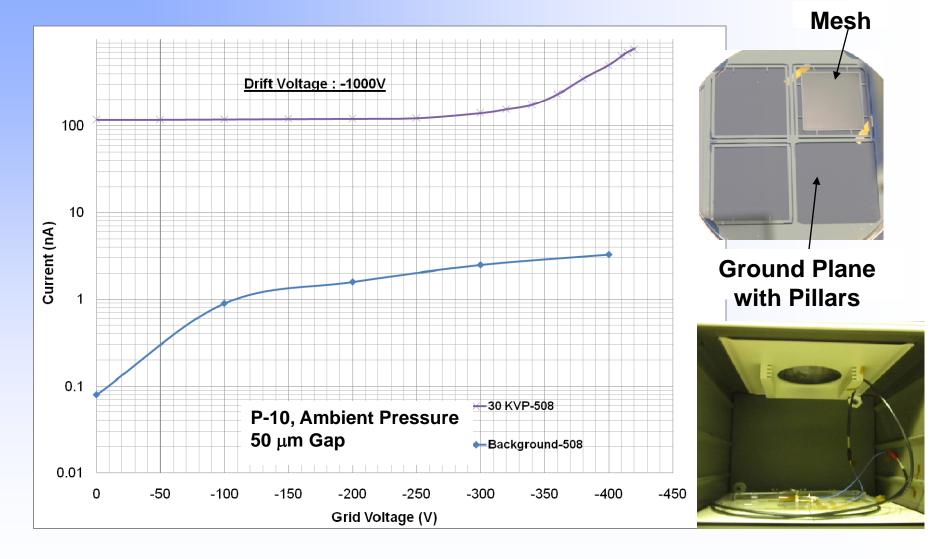
Micromegas via Micro-Fab Process



There are 474 X 474 36 um diameter holes within one square inch mesh area, 54 um pitch. Pillars are 64 um diameter on a 156 um pitch.



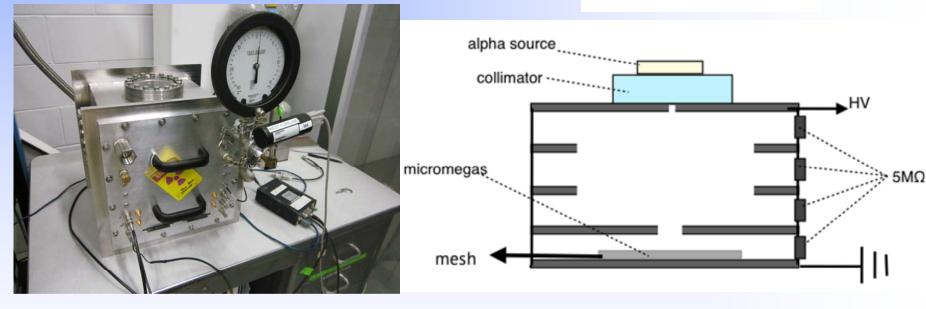
X-Ray Detection

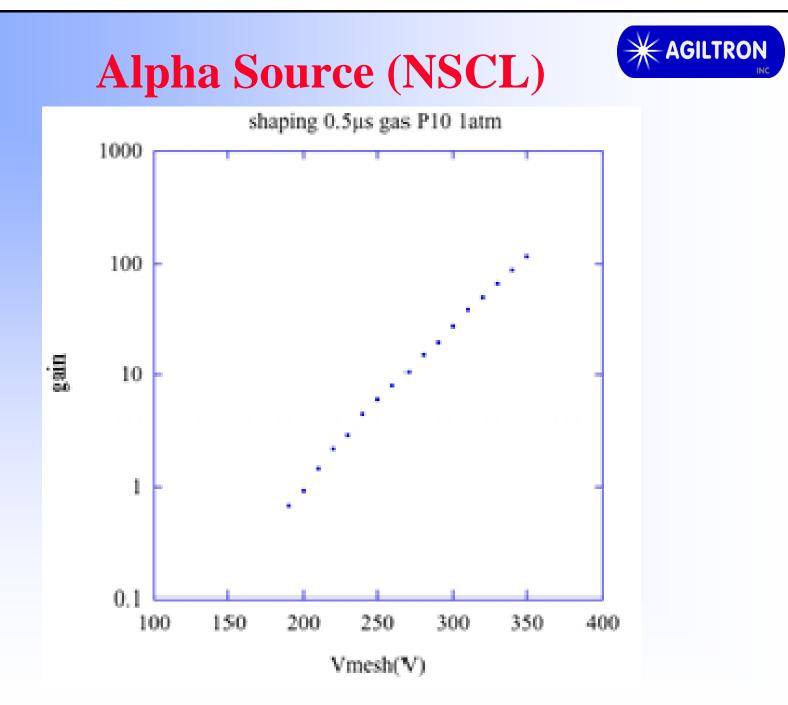


Alpha Radiation (NSCL)



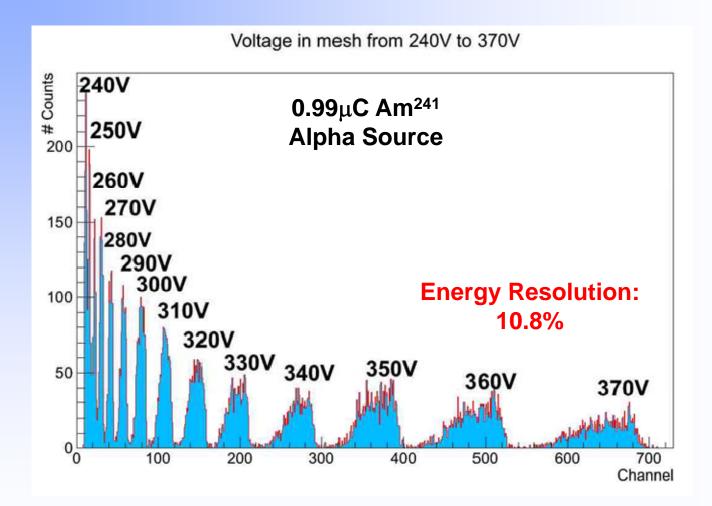
0.99µC Am²⁴¹ Alpha Source







Alpha Source (NSCL)



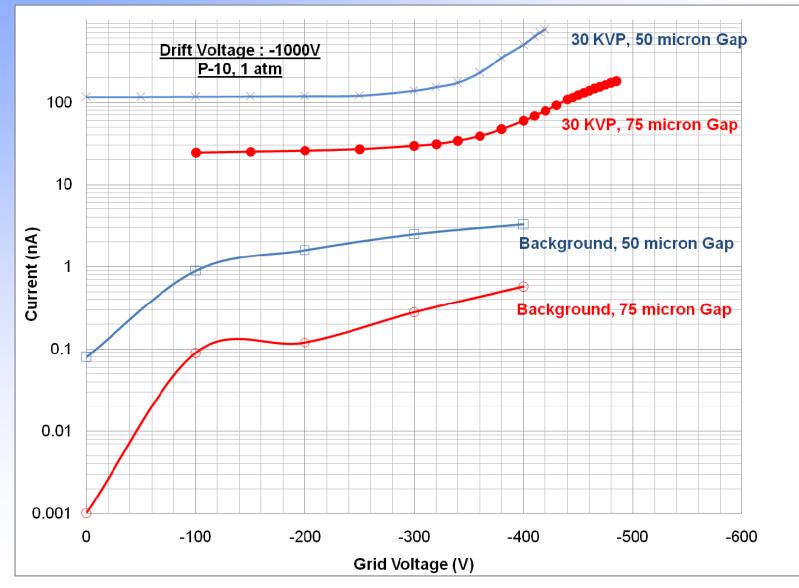
Recent Improvements



- In crease mesh gap to 75 μm from 50 μm.
- Redesigned the masks and micro-fab procedures have improved yield to over 75%
- Redesigned the masks to accommodate large area device fabrication via stitching of meshes



Improved Micromegas





Q & A